

IN THE CLAIMS

Please amend the claims as follows:

Claim 1 (Currently Amended): A method of making a master for manufacturing an optical disc, comprising:

~~an exposing step of irradiating~~ an inorganic resist layer formed on a substrate [[with]]
to recording laser light modulated by an information signal corresponding to an information
signal of an information concave and convex pattern formed on said optical disc to form an
exposed pattern corresponding to said information concave and convex pattern of said optical
disc, and

~~after the preceding step a developing step of performing development processing on~~
said inorganic resist layer to form a concave and convex pattern corresponding to said
information concave and convex pattern of said inorganic resist layer, wherein

~~in said exposing process, after~~ a trial exposure is performed on a non-recording area
of said resist layer, evaluation laser light is irradiated on the ~~exposed portion~~ non-recording
area of said resist layer to evaluate a recording signal characteristic of said resist layer from
the reflected light, and based on an evaluation result, an adjustment of an exposure focusing
position is performed to determine an optimum focus position of recording laser light which
is later performed.

Claim 2 (Original): The method of making a master for manufacturing an optical disc
according to claim 1, wherein said inorganic resist layer is a resist layer containing an
incomplete oxide of transition metals.

Claim 3 (Original): The method of making a master for manufacturing an optical disc according to claim 1, wherein an area irradiated with said evaluation laser light is an area other than an area irradiated with said recording laser light.

Claim 4 (Original): The method of making a master for manufacturing an optical disc according to claim 2, wherein an area irradiated with said evaluation laser light is an area other than an area irradiated with said recording laser light.

Claim 5 (Currently Amended): A method of manufacturing an optical disc comprising the steps of:

making a master for manufacturing the optical disc;

making a stamper for manufacturing the optical disc from said master through transcription;

manufacturing an optical disc substrate using said stamper through transcription;

forming a reflective film on the optical disc substrate₁; and

forming a protective film,

~~wherein, the step of making said master includes:~~

[[an]] wherein making a master for manufacturing the optical disc includes:

exposing ~~step of irradiating~~ an inorganic resist layer formed on the substrate

[[with]] to recording laser light modulated by an information signal corresponding to

an information signal of an information concave and convex pattern formed on said

optical disc to form an exposed pattern corresponding to said information concave and

convex pattern on said optical disc, and

~~after the preceding step a step of~~ performing development processing on said inorganic resist layer to form a concave and convex pattern corresponding to said information concave and convex pattern of said inorganic resist layer[[]; and]],

~~in said exposing step, after~~ wherein a trial exposure is performed on a non-recording area of said resist layer, evaluation laser light is irradiated on the ~~exposed portion~~ non-recording area of said resist layer to evaluate a recording signal characteristic of said resist layer from the reflected light, and based on an evaluation result an adjustment of exposure focusing position is performed to determine an optimum focus position of recording laser light which is later performed.

Claim 6 (Original): The method of manufacturing the optical disc according to claim 5, wherein said inorganic resist layer is a resist layer containing an incomplete oxide of transition metals.

Claim 7 (Original): The method of manufacturing the optical disc according to claim 5, wherein an area irradiated with said evaluation laser light is an area other than an area irradiated with said recording laser light.

Claim 8 (Original): The method of manufacturing the optical disc according to claim 6, wherein an area irradiated with said evaluation laser light is an area other than an area irradiated with said recording laser light.